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This appln claims benefit of 60/410,067 09/11/2002  
 and is a CIP of 10/400,054 03/25/2003 PAT 6,936,086  
 which claims benefit of 60/410,067 09/11/2002

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Nor Jos*

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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY OR	SHEETS DRAWING 9	TOTAL CLAIMS 42	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials				

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## TITLE

Precursor material delivery system for atomic layer deposition